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Attorney Docket No.: 042390.P7832

A TRADEM IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Li-Shun Wang, John Chu

Serial No.: 09/476,633

Filed: December 31, 1999

For: REMOVAL OF RESIDUE FROM A SUBSTRATE

Art Unit: 2823

Examiner: Garcia, J.



RESPONSE TO FINAL OFFICE ACTION

Box AF Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In connection with the Final Office Action (the "FOA") mailed on December 17, 2001 regarding the above-referenced Application, the Applicants respectfully request consideration of the following remarks.

REMARKS

In response to the FOA, no claims have been amended, no claims have been cancelled and no claims have been added. Accordingly, Claims 1-4 and 6-28 are pending.

Claims 1-4, 7, 9-12, 18, 19 and 26-28 are rejected under 35 U.S.C. §102(e). Claims 6, 8, 13, 14, 16, 17 and 20-22 are rejected under 35 U.S.C. §103(a). Claims 23-26 are rejected under 35 U.S.C. §112, first paragraph.

I. <u>35 U.S.C. § 102(e): Rejection of Claims 1-4, 7, 9-12, 18, 19 and 26-28</u>

Claims 1-4, 7, 9-12, 18, 19 and 26- 28 are rejected under 35 U.S.C. § 102(e) as anticipated by U.S. Patent No. 6,159,858 to Kishii et al ("Kishii"). The Patent Office characterizes <u>Kishii</u> as "rinsing the surface of the metal plug with a solution comprising hydrogen peroxide." (see page 2, Office Action, mailed June 20, 2001). Applicants respectfully submit that the Patent Office continues to mischaracterize <u>Kishii</u>. <u>Kishii</u> does not disclose <u>rinsing</u> the surface of a plug; only <u>cleaning</u> of a substrate using a <u>cleaning solution</u> containing acid, hydrogen peroxide and water, so as to dissolve abrasive material is disclosed. (See <u>Kishii</u>, col. 14, lines 49-50, and